

すばる望遠鏡およびTMT、E-ELT用の 新しい回折格子

Novel gratings for Subaru Telescope, TMT and E-ELT

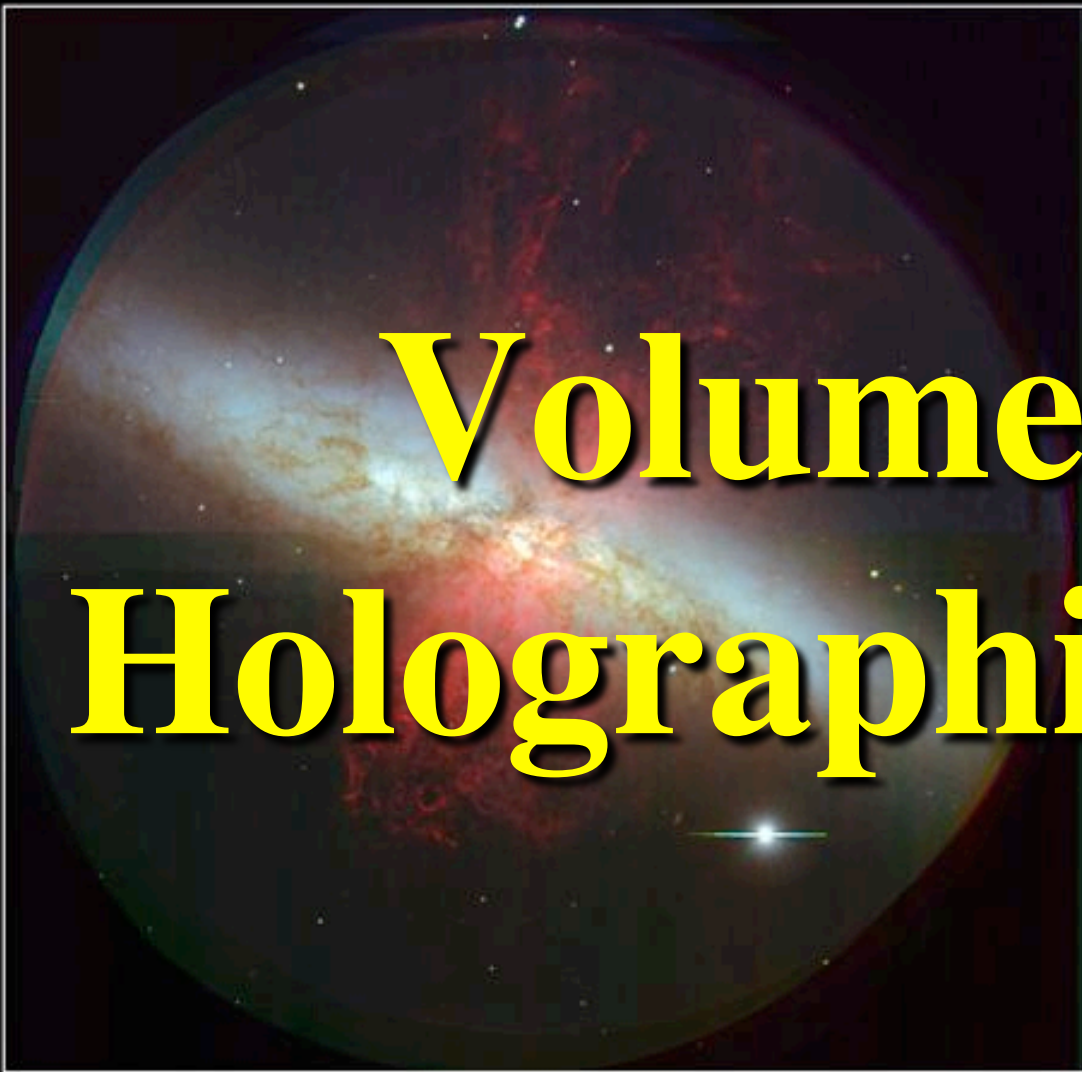
Noboru Ebizuka, Kenji Ishikawa, Hiroki Kondo, Masaru Hori,
(Plasma Nanotechnology Research Center, Nagoya University)

Andrea Bianco, Filippo Maria Zerbi
(INAF Osservatorio Astronomico di Brera, Italy)

すばる将来装置計画ワークショップ

January 18, 2011

Volume Phase Holographic Grating



M 82 (NGC 3034)

Subaru Telescope, National Astronomical Observatory of Japan

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FOCAS (B, V, H α)

March 24, 2000



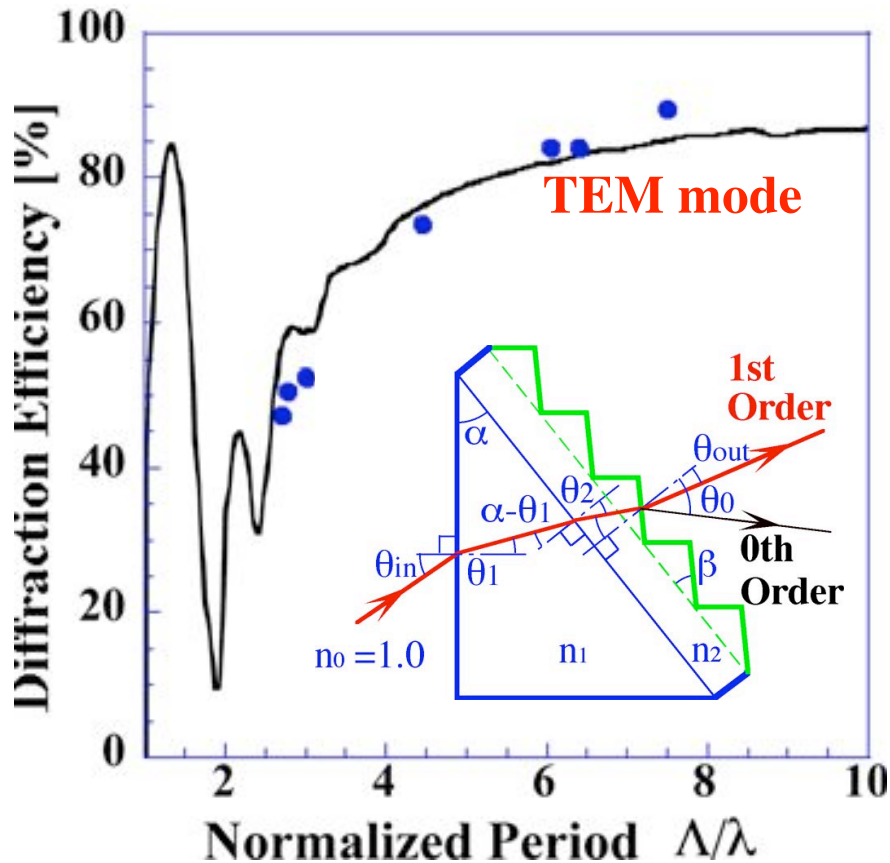
Hickson Compact Group 40

Subaru Telescope, National Astronomical Observatory of Japan

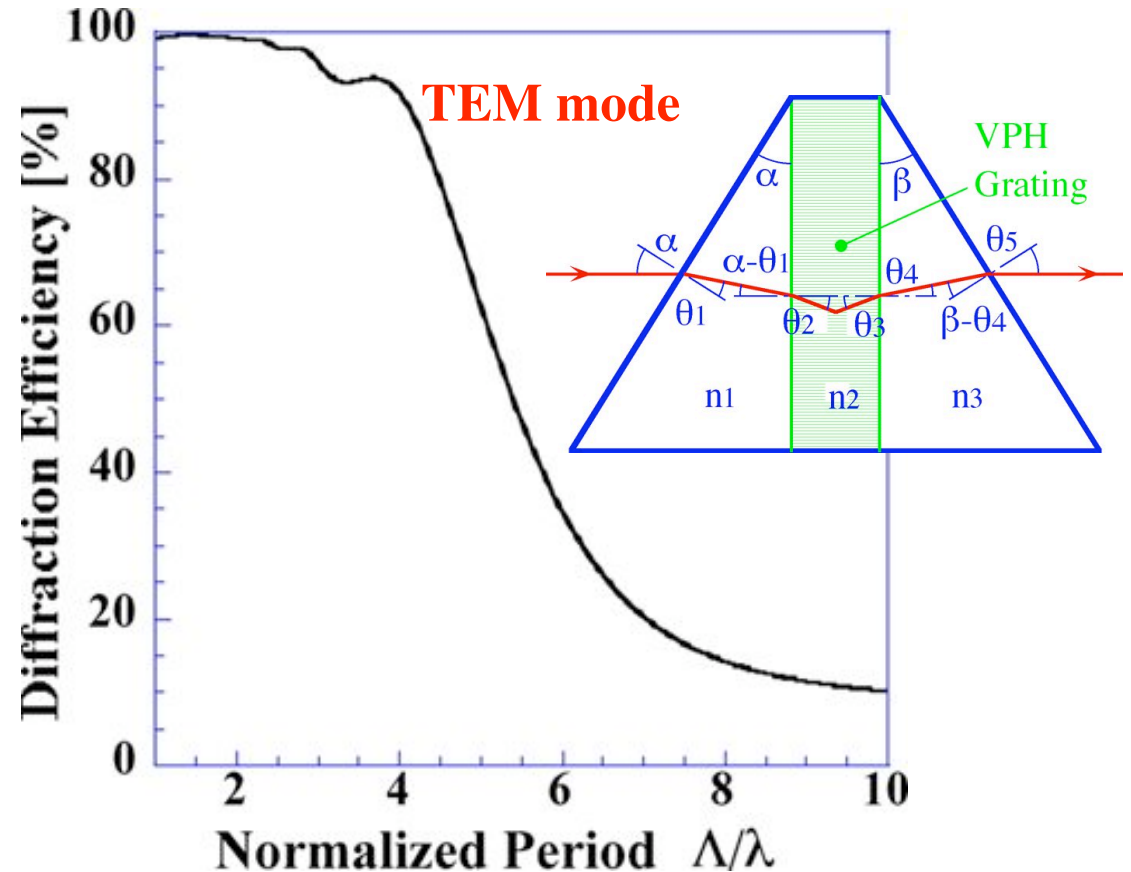
CISCO (J & K')

January 28, 1999

Efficiencies of Gratings



Surface relief grating:
Efficiency decreases
steeply below $4 \Delta/\lambda$



VPH (Volume Phase Holographic) grating ($\Delta n \sim 0.02$): Efficiency increases up to 100% below $4 \Delta/\lambda$.

(K. Oka et. al., SPIE 5005, 2003)

Fabrication of Hologram Plate

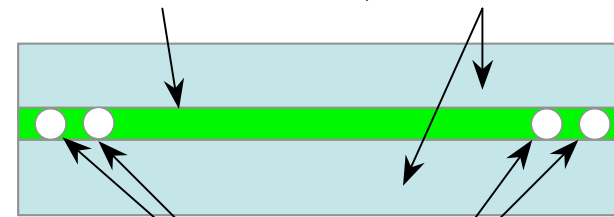
Cleaning of substrates
(Hand polish)

Dropping liquid hologram
resin onto a substrate,
heating up to 80°C

Covered by another
substrate. **Thickness** of
resin layer is given by
glass or plastic beads.

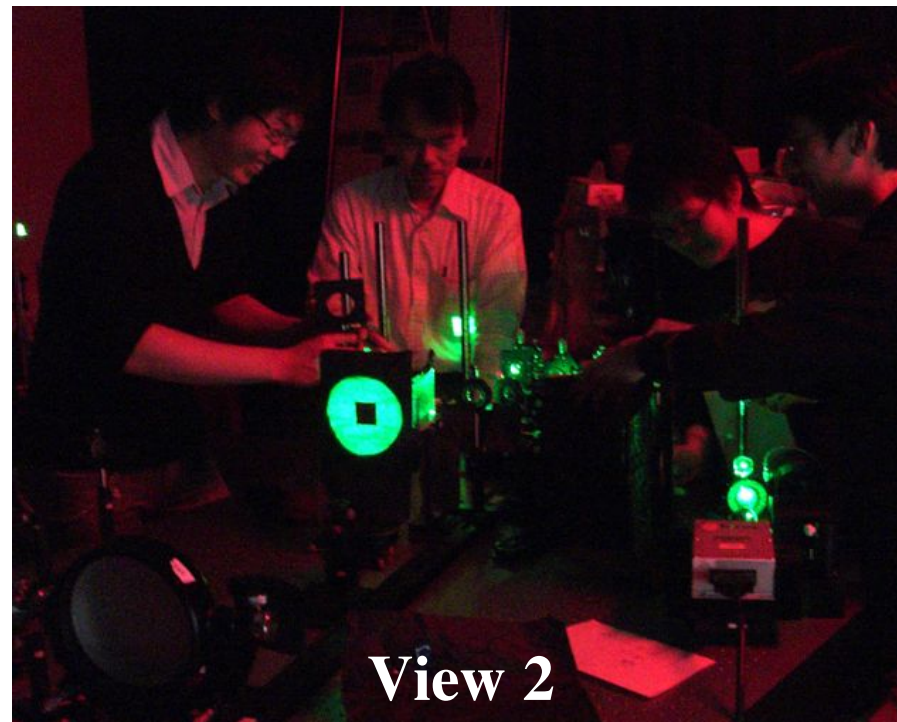


Hologram resin
(Nippon Paint Co. Ltd.) **Glass**
substrates



Glass beads

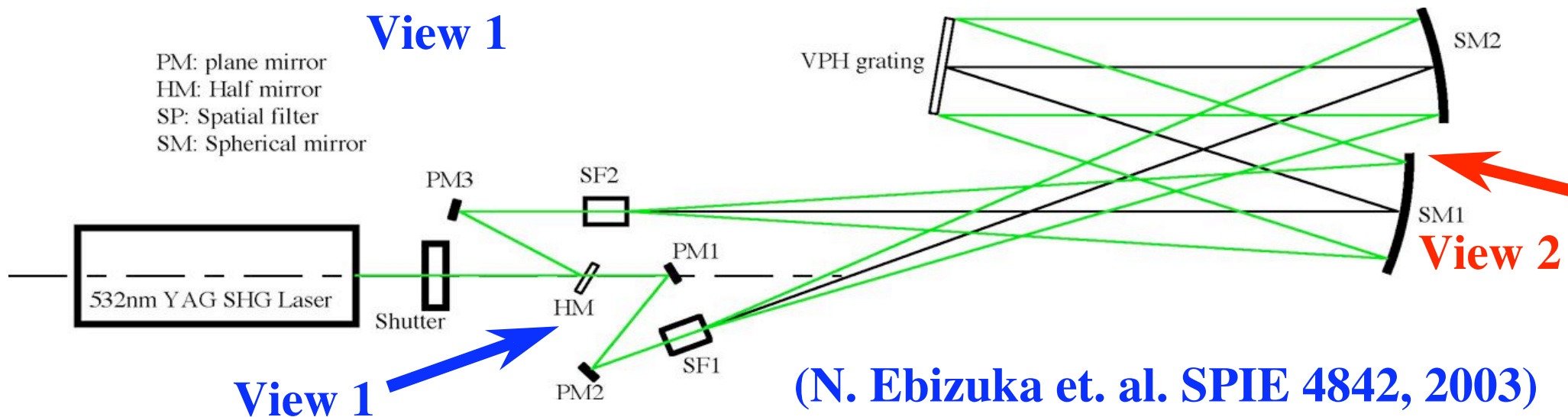
Two Beam Interferometer for Holographic Exposure



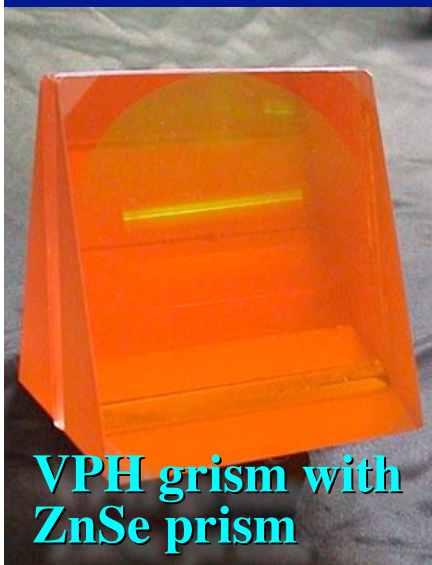
View 1

View 2

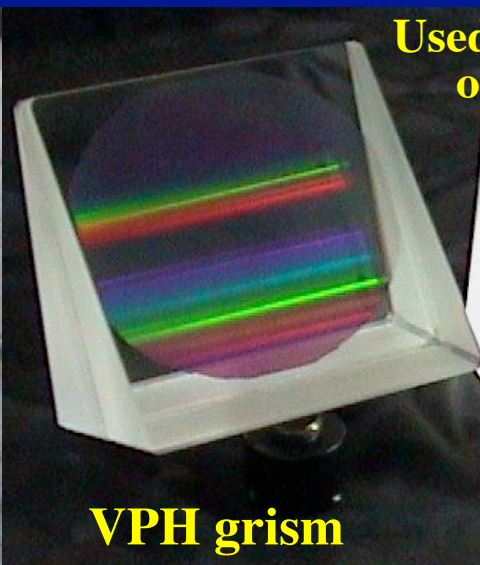
PM: plane mirror
HM: Half mirror
SP: Spatial filter
SM: Spherical mirror



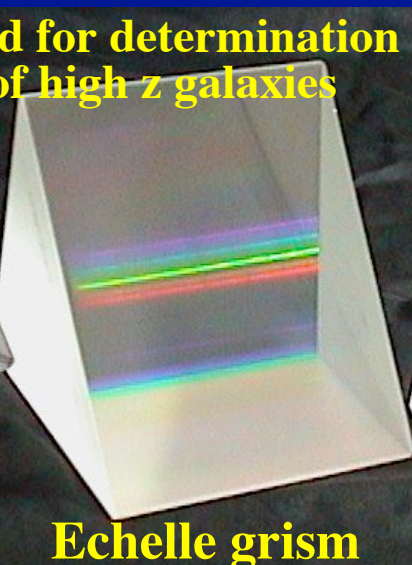
(N. Ebizuka et. al. SPIE 4842, 2003)



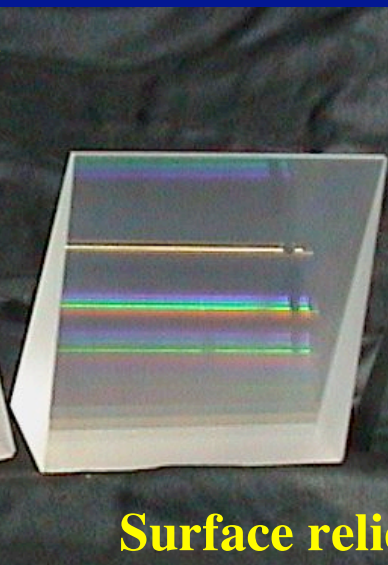
VPH grism with ZnSe prism



VPH grism



Echelle grism



Surface relief grism

Used for determination of high z galaxies

FOCAS Grisms

Size: $110 \times 106 \times 106$ (max).

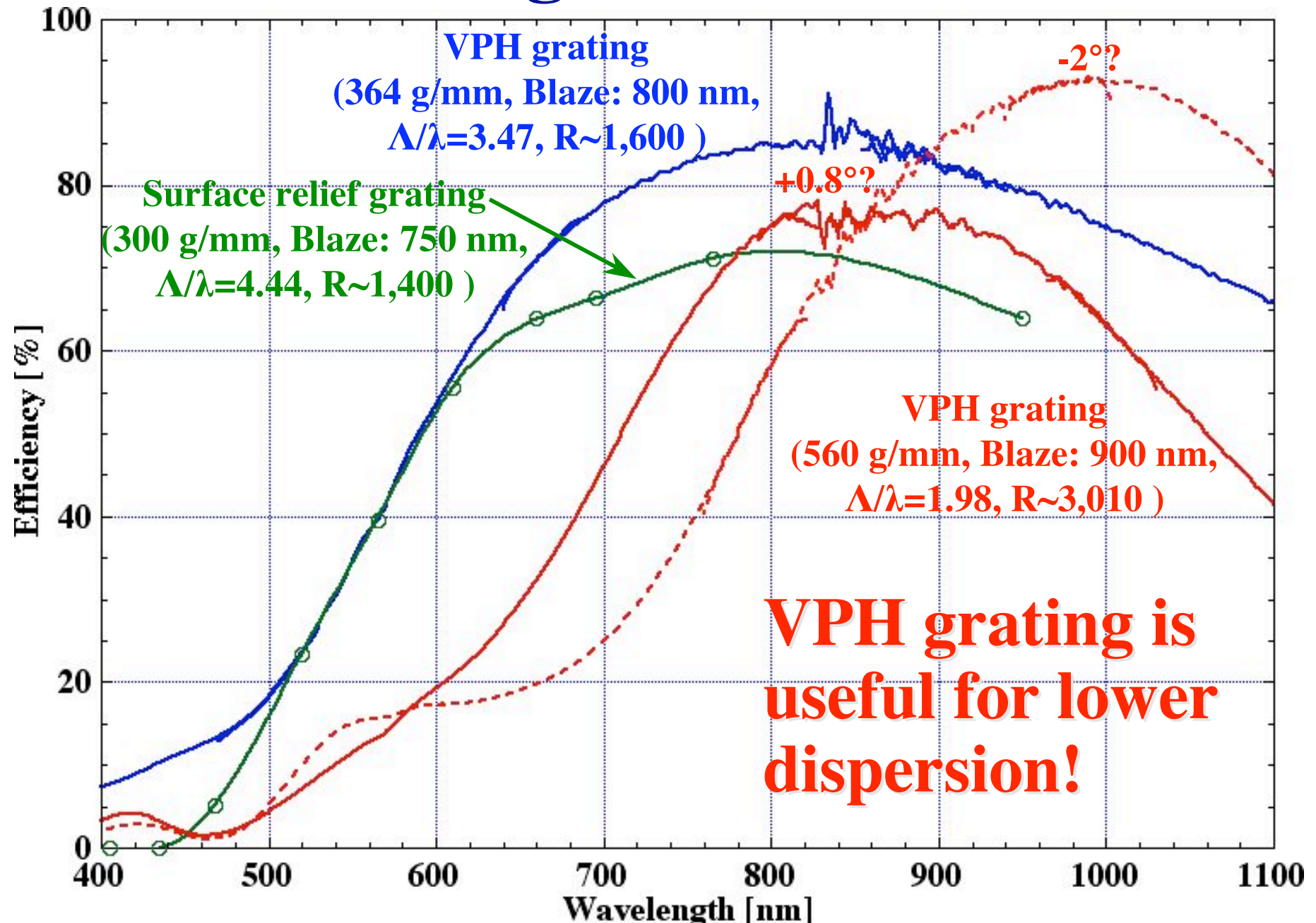
4 SR grisms: $300 < R < 1,400$.

1 Echelle grism: $R \sim 2,500$.

8 VPH grisms (3 grisms with ZnSe prisms): $1,600 < R < 7,000$,
Collaboration of JWU (Japan Women's Univ.) and NAOJ.

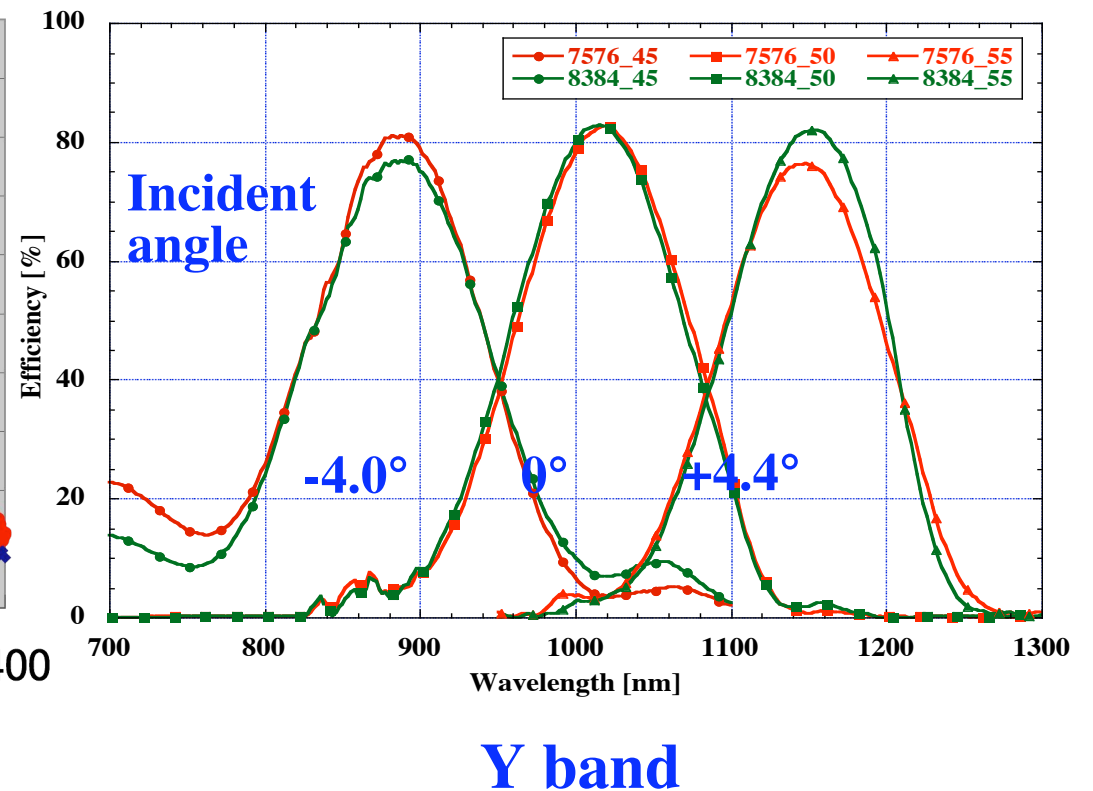
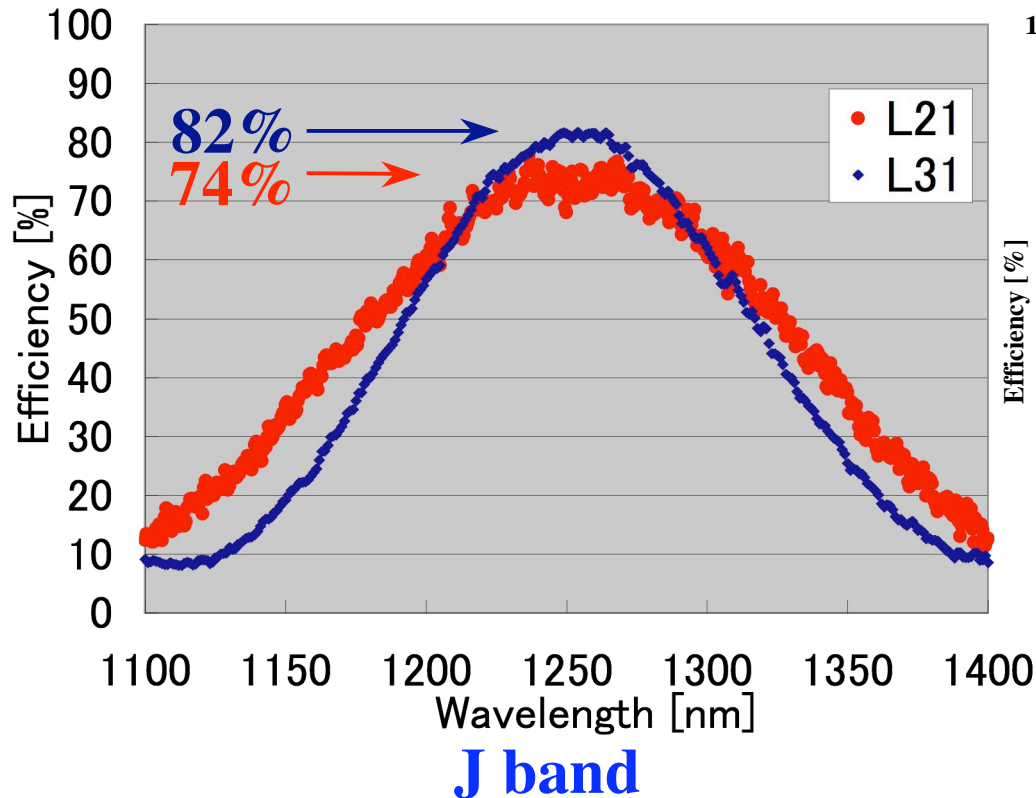


New VPH gratings for FOCAS

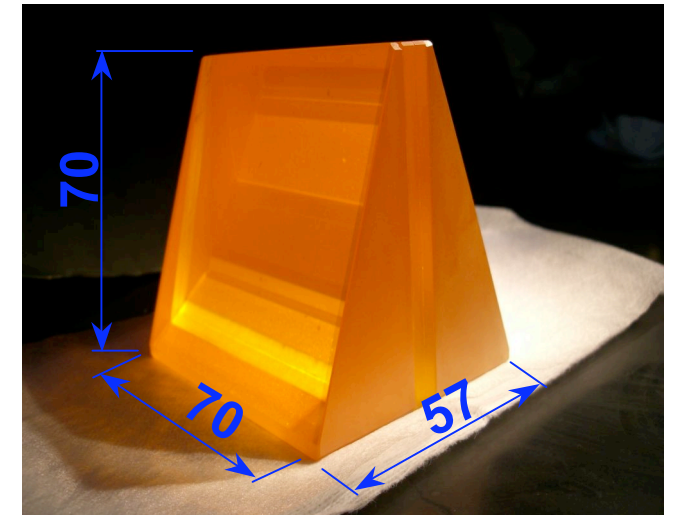
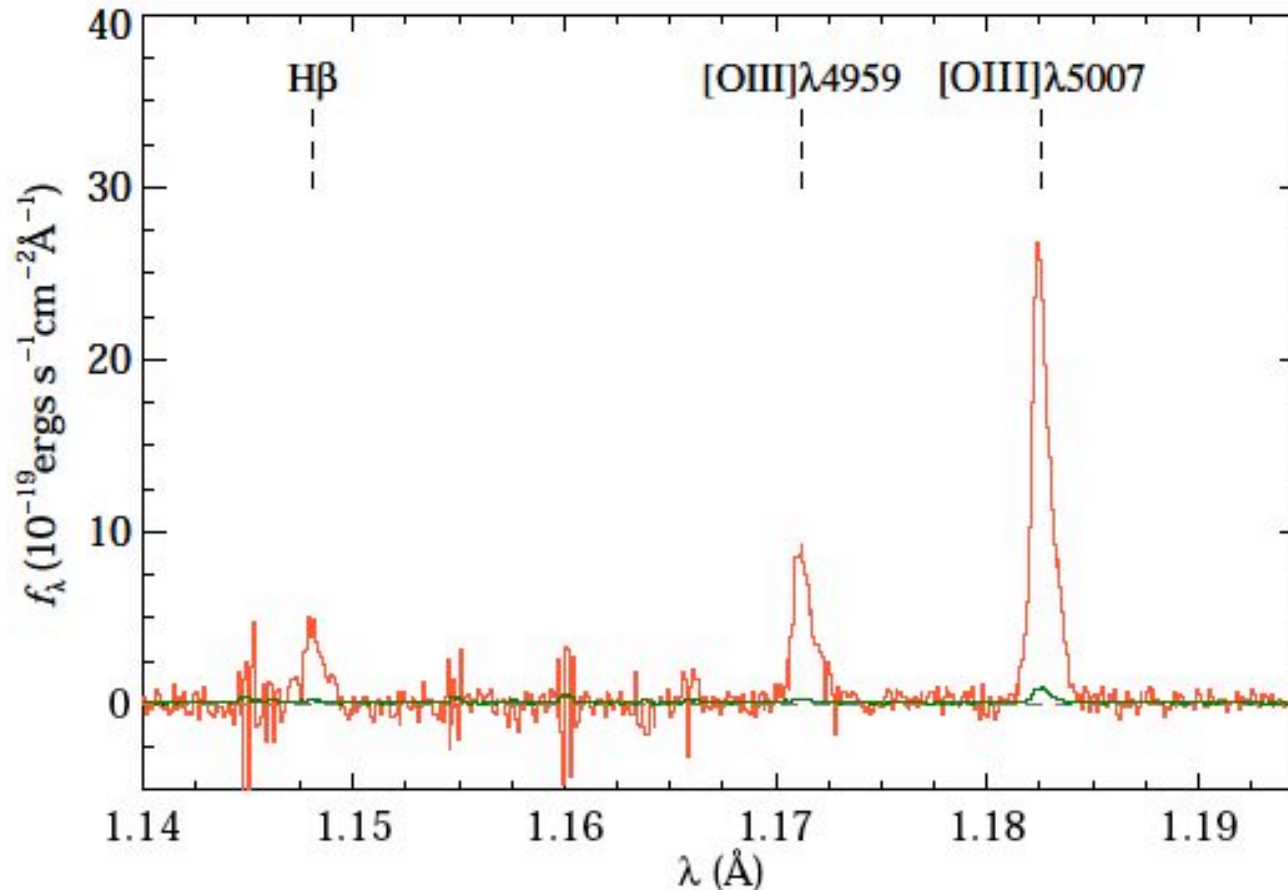


MOIRCS VPH grisms

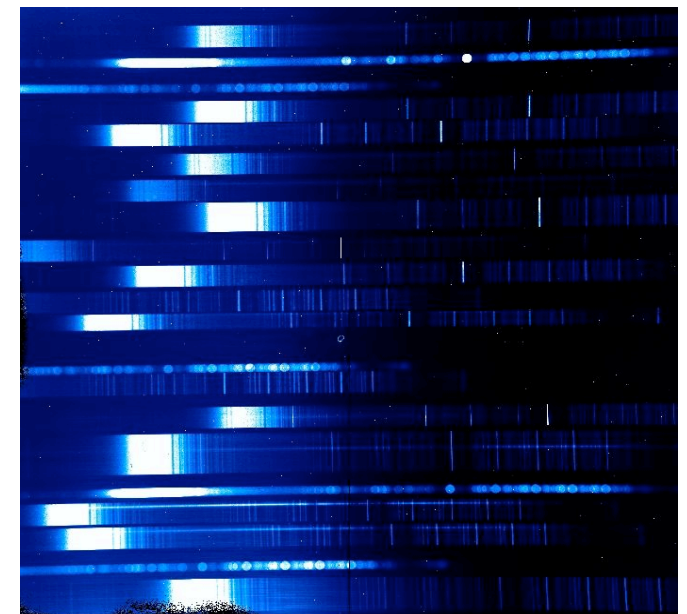
Band	Center [μm]	Range [μm]	R ($\Delta\lambda/\lambda$) @0.5" Slit	Efficiency (Peak)	Developer
Y	1.02	0.94 – 1.09	3,200	~ 0.80	Soma Opt.
J	1.25	1.13 – 1.37	3,100	0.82, 0.74	Tohoku Univ.
H	1.65	1.52 – 1.78	3,000	~ 0.75	Tohoku Univ.
K	2.20	2.00 – 2.40	2,600	> 0.80	JWU



Spectrum of High-z Galaxy ($z = 1.618$)



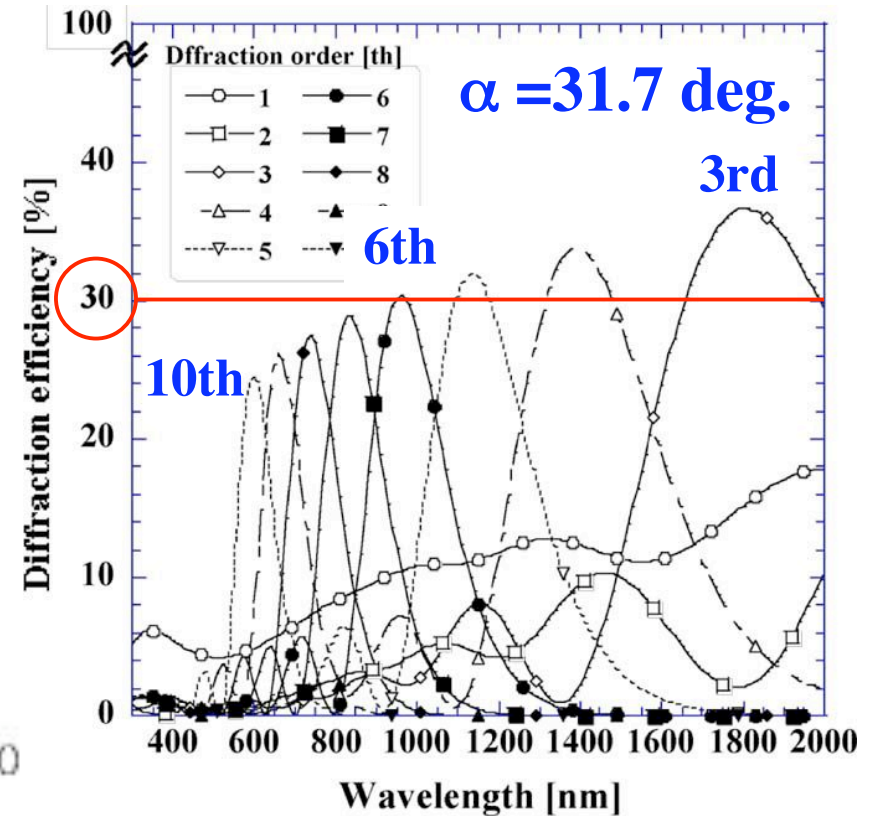
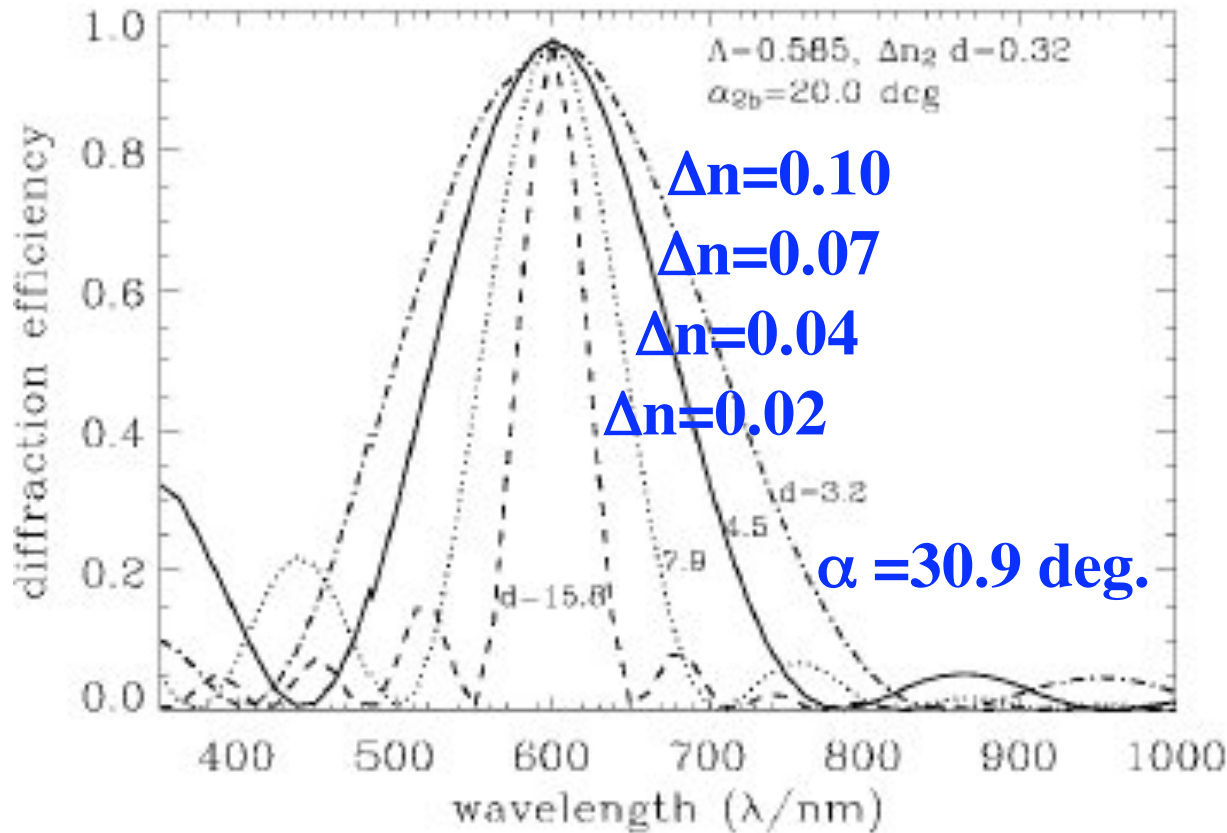
Size: 70 x 70 x 57 (max) mm.



MOIRCS, J band VPH grism ($R \sim 3,000$), 0.8'' slit [Onodera in private communication].

(T. Ichikawa et. al., SPIE 7014, 2008)

Limitation of VPH grating



Band width of VPH grating becomes narrow in diffraction angle: α above 30 degree because semi-amplitude of index modulation (Δn) of dichromated gelatin (DCG) is **up to 0.15~0.2**.
 (Baldry et al., PASP, 116, 2004)

Diffraction efficiency of VPH grating decrease toward higher orders.
 (Oka et. al., SPIE, 5290, 2004)

A deep space photograph of the Horse-head Nebula, showing a dark, horse-head-shaped structure against a reddish-pink nebula. The text is overlaid on the image.

Grating Used for Higher Diffraction Orders



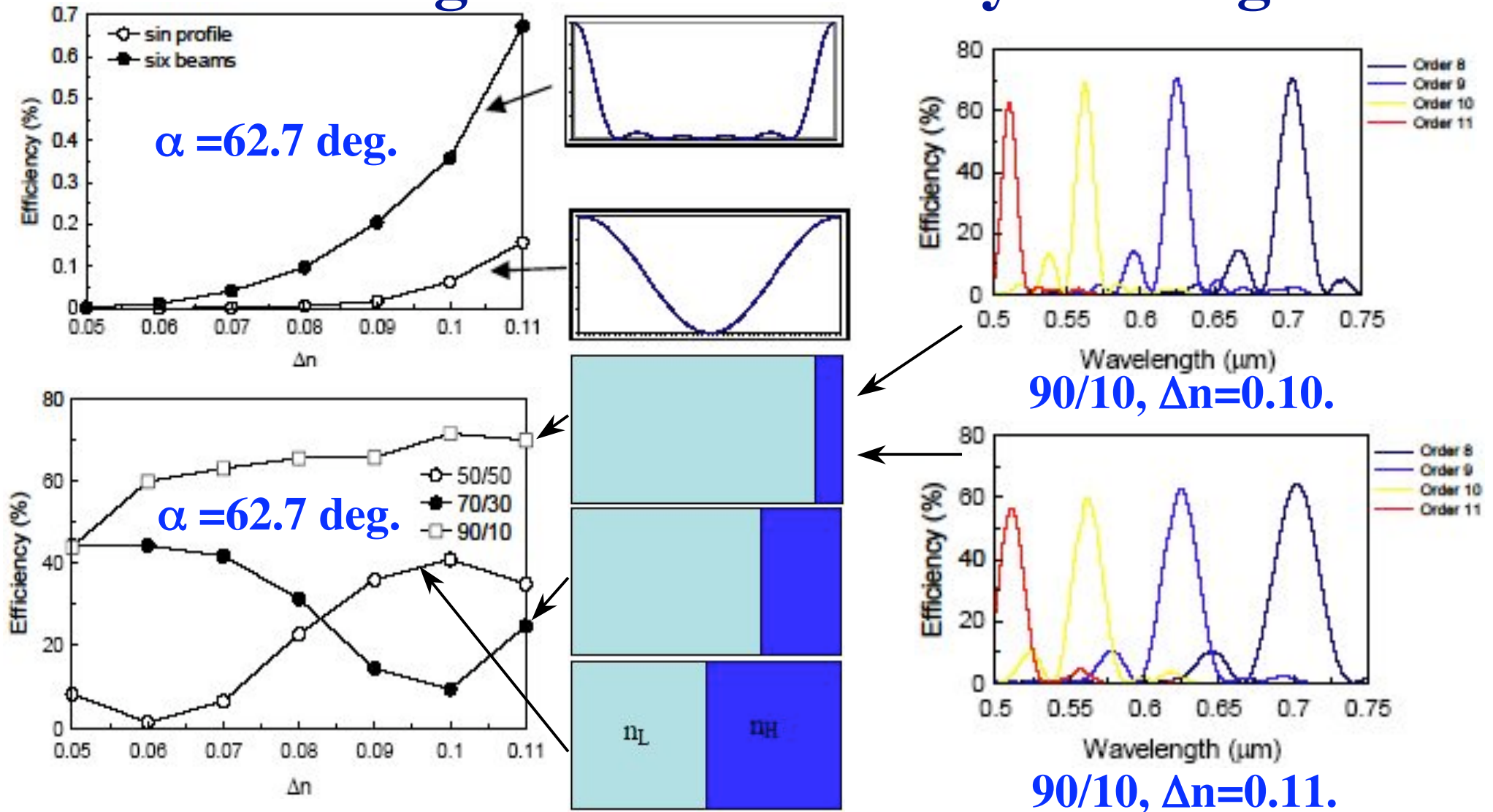
IC 434 (Horse-head Nebula)

Ultra-high-sensitivity HDTV I.I. color camera (NHK)
Exp. 22 sec. (11 frames coadded) January 16, 1999

Subaru Telescope, National Astronomical Observatory of Japan

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Diffraction Efficiencies of VPH Grating and Thick Binary Grating



VPH gratings (above) and binary gratings (below) at the 9th order.

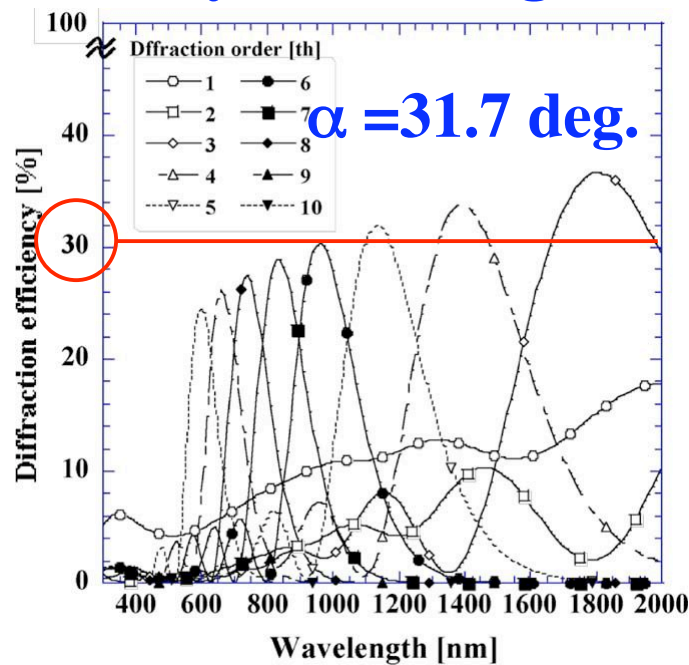
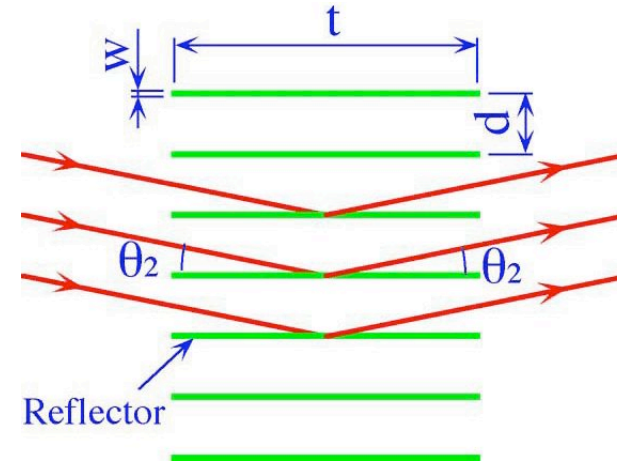
(Bianco et al. SPIE 7739, 2010)



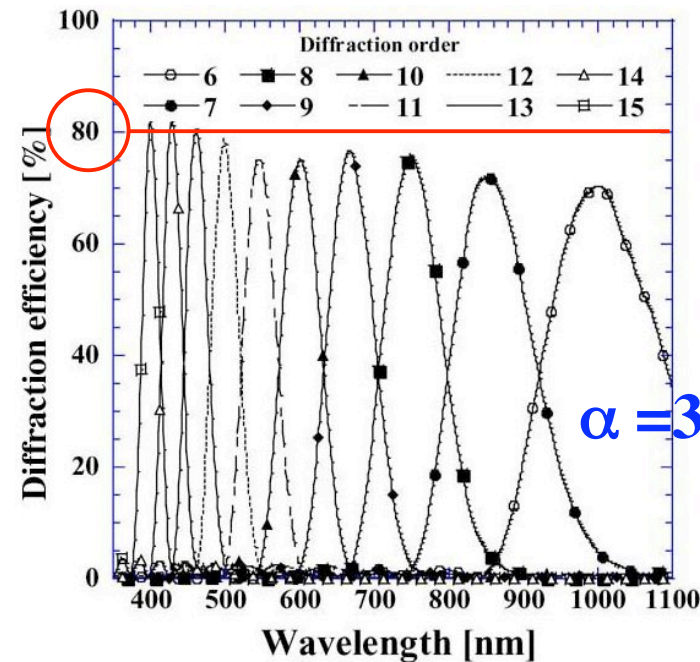
Echellegram

- SR grating slightly changes spectral characteristics.
- VPH grating becomes lower efficiency toward higher order.

Quasi-Bragg Grating



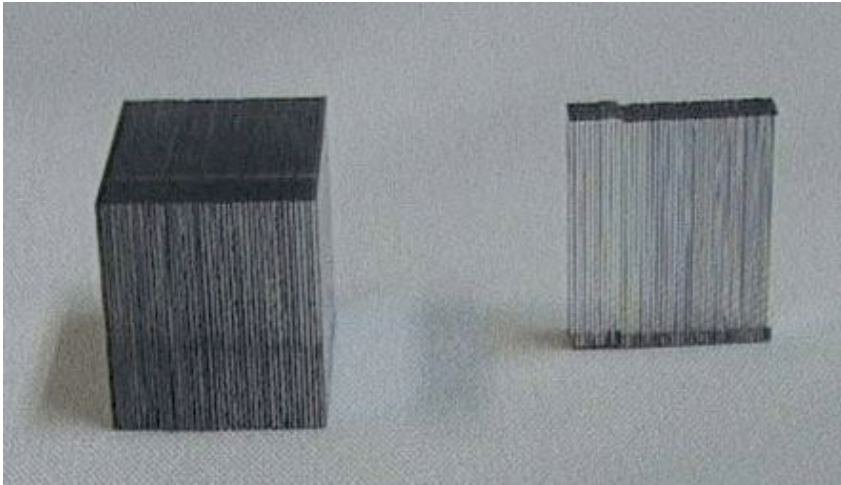
VPH grating



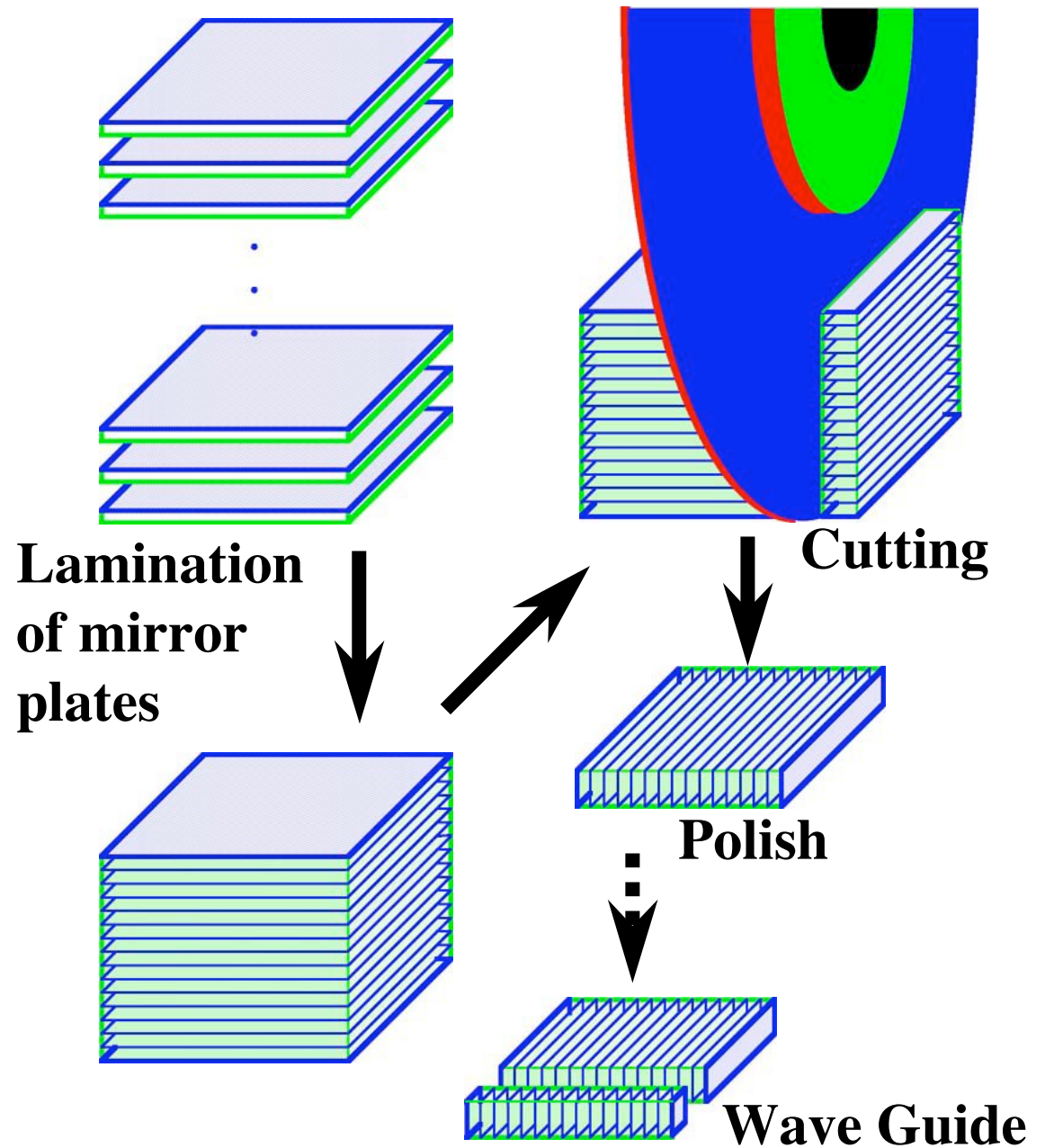
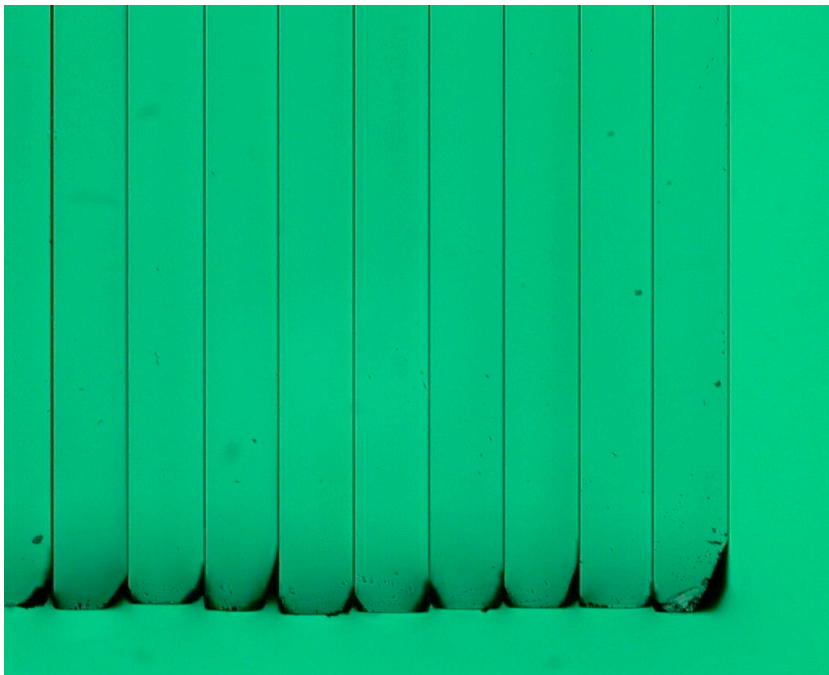
Quasi-Bragg grating

(Oka, et. al., SPIE 5290, 2004)

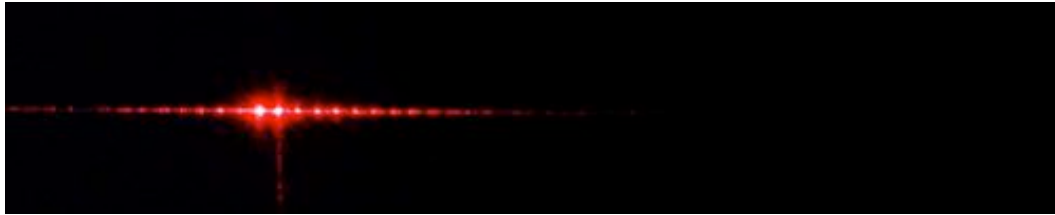
Trial Fabrication of Quasi-Bragg Grating



A: 10 x 10 x 0.2 x 40 pieces (Left),
B: 1.5 x 10 x 0.2 x 40 pieces (Right)



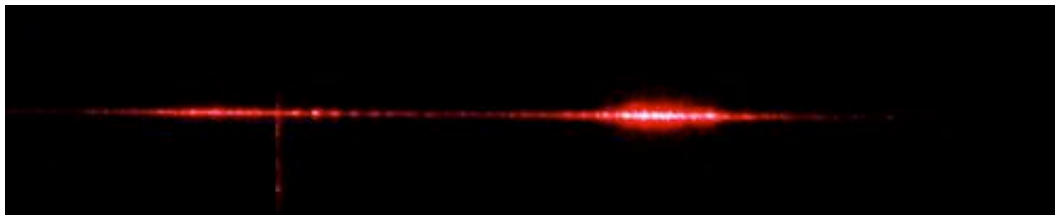
Diffraction by Quasi-Bragg Grating



Vertical ($\theta = 0$)



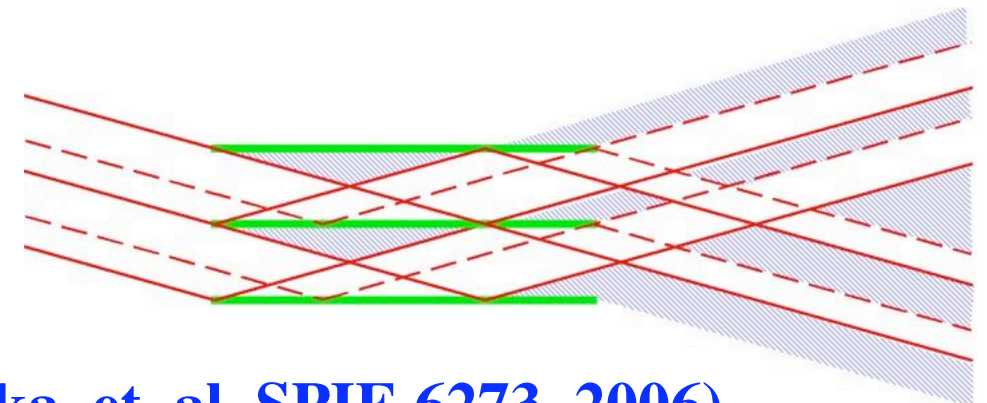
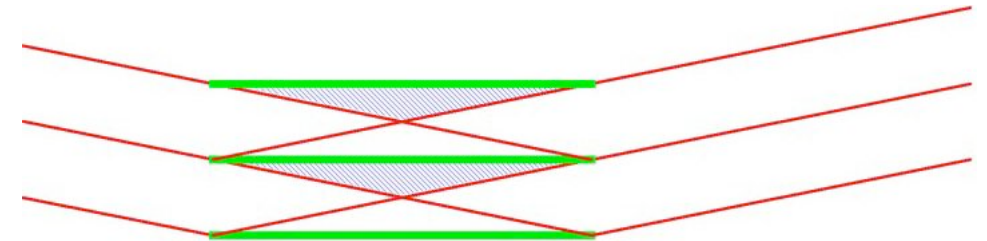
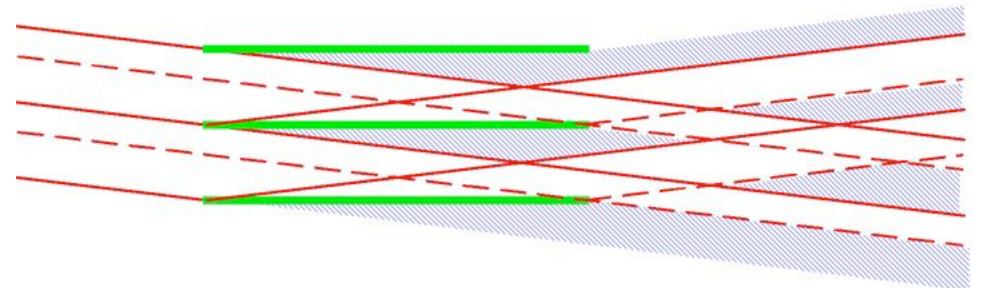
Small incident angle ($\theta = 0.6$)



Ideal incident angle ($\theta = 1.2$)



Large incident angle ($\theta = 1.8$)



(Ebizuka, et. al. SPIE 6273, 2006)



Immersion Grating



Orion Nebula

Subaru Telescope, National Astronomical Observatory of Japan

CISCO (J, K' & H₂ ($v=1-0$ S(1)))

January 28, 1999



Star-forming Region S106 IRS4

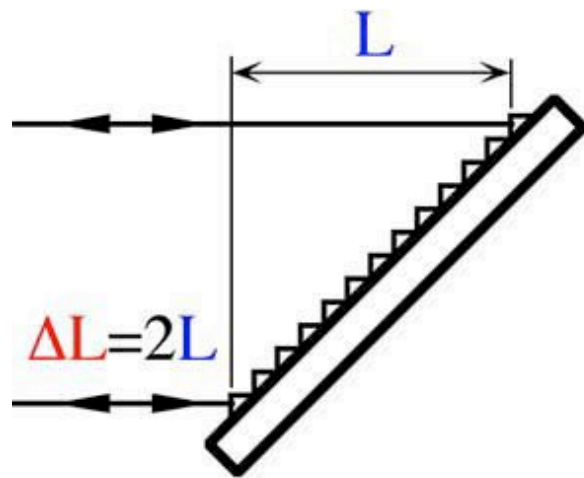
Subaru Telescope, National Astronomical Observatory of Japan

CISCO (J, H, K')

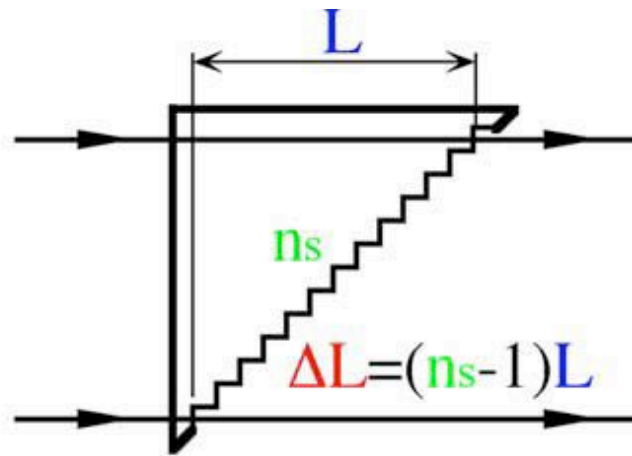
February 13, 2001

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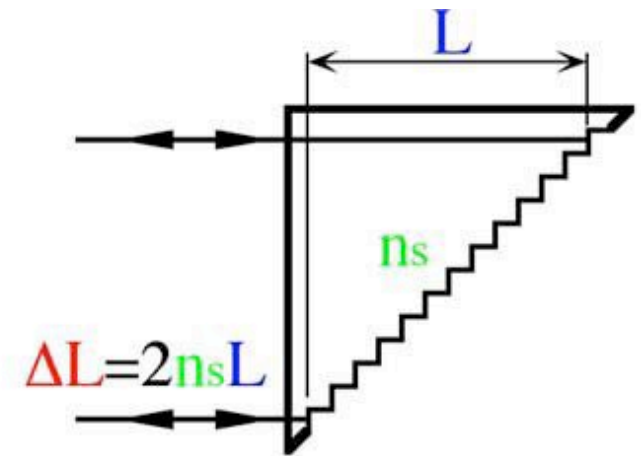
Development of High Dispersion Gratings



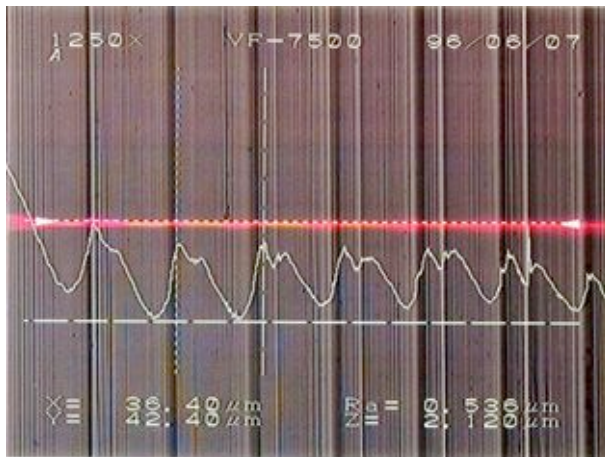
(a) Reflection grating



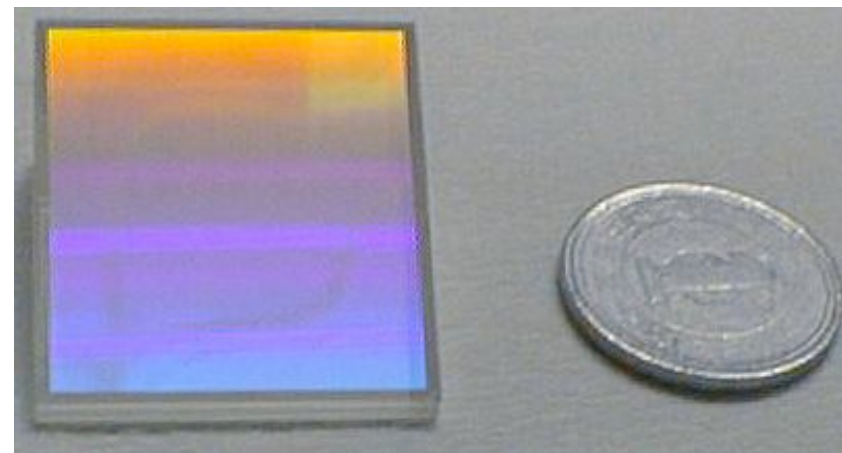
(b) Grism



(c) Immersion grating

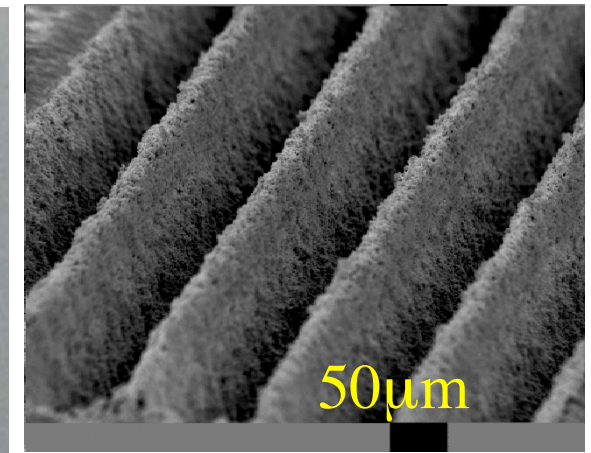


LiNbO_3 ($n = 2.3$)
grating, 30 g/mm,
Dicing Saw



LiNbO_3 ($n = 2.3$) Grism,
444 g/mm, Ion etching

(Ebizuka et. al. SPIE 3355, 1998)

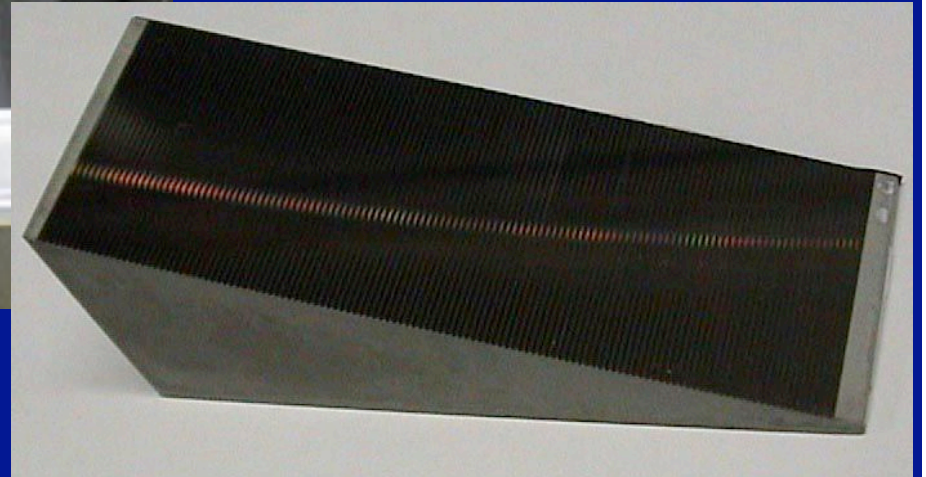
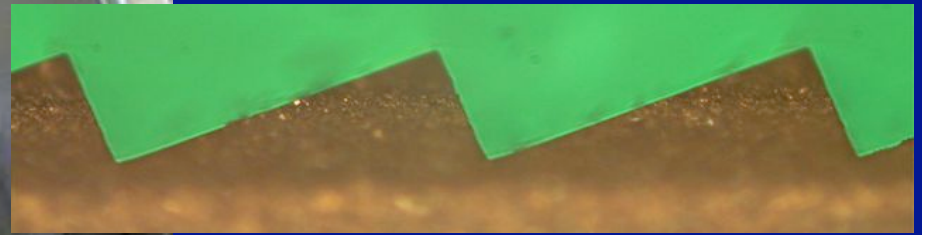


Ge ($n=4.0$) grating,
Excimer Laser
Ablation

Fabrications of Germanium Immersion Grating for Prototype IRHS

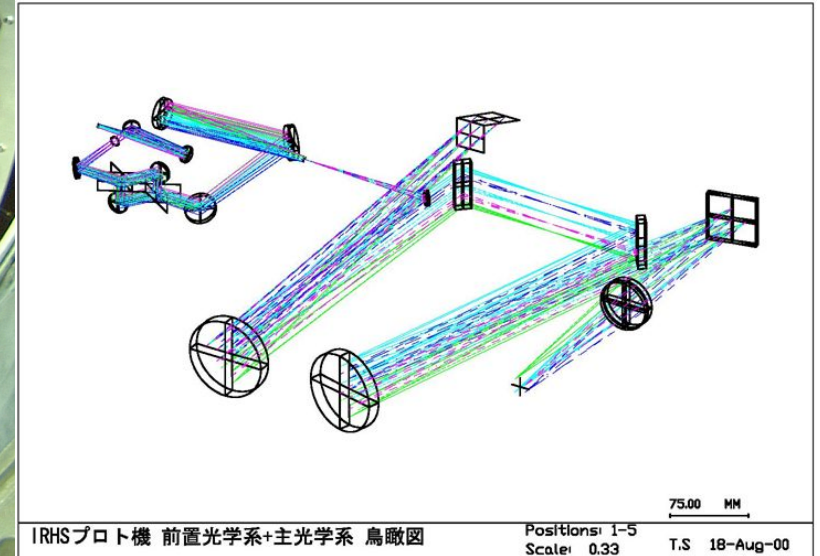
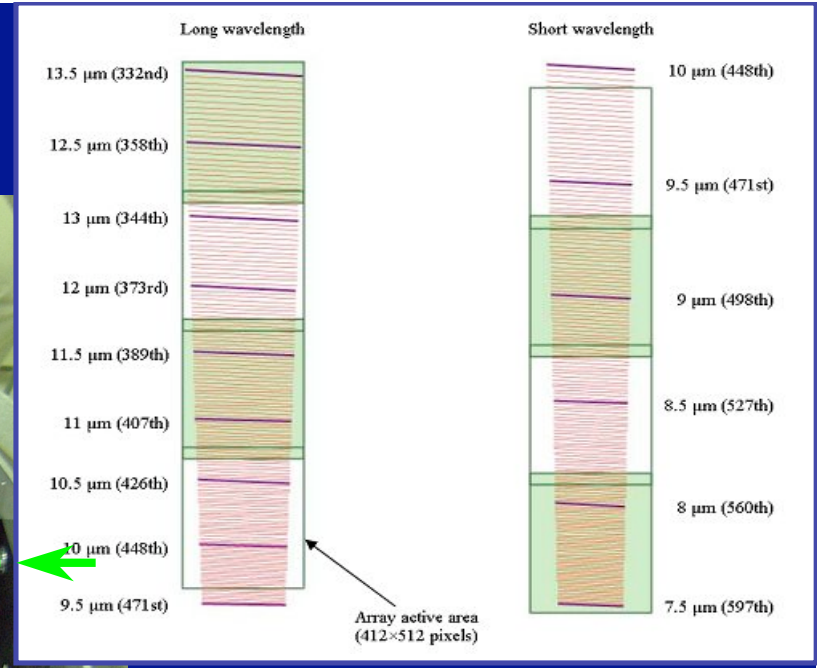
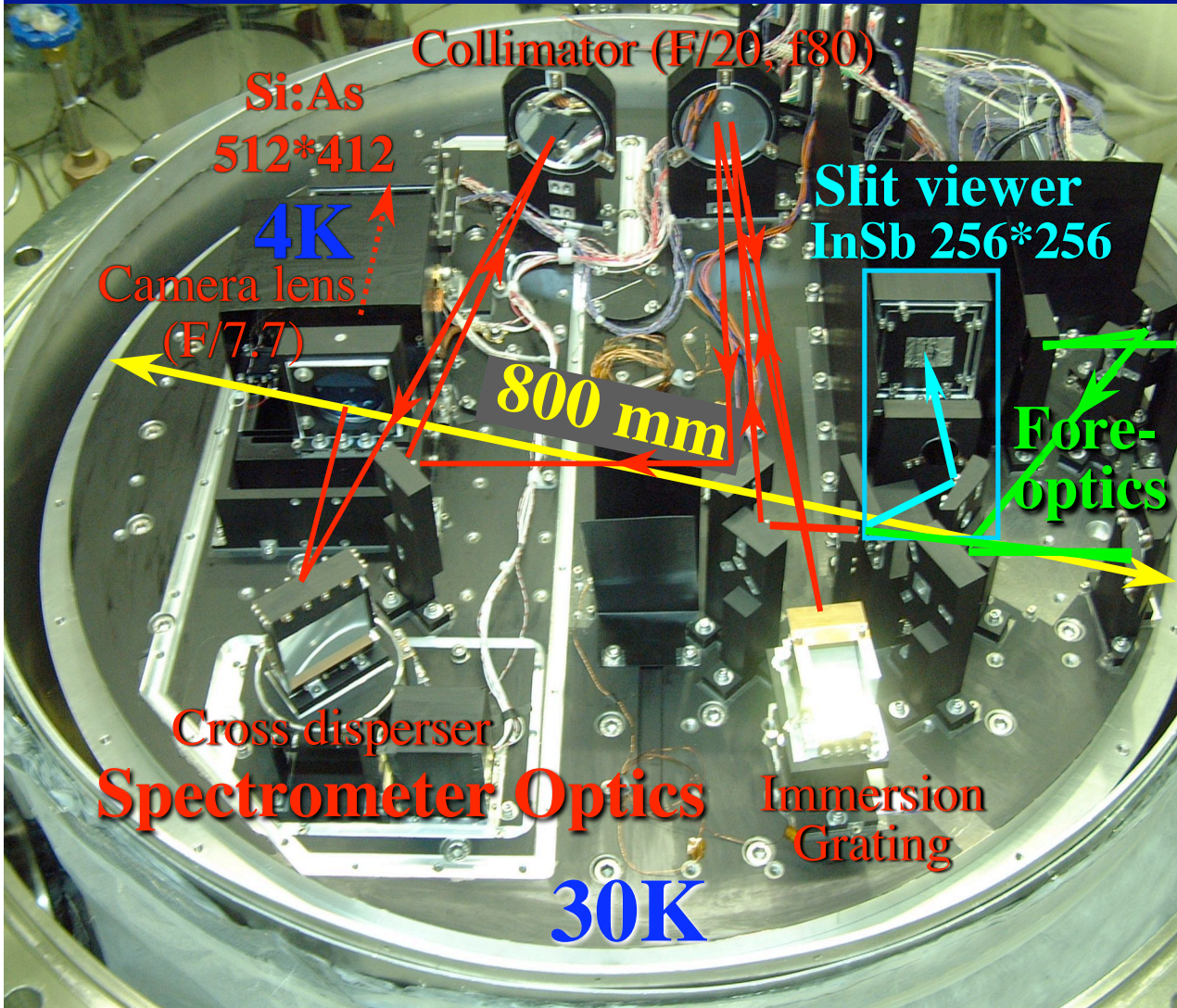


Nano precision machine and ELID grinding method.
30 x 30 x 72 [mm],
 $\alpha = 68.75^\circ$



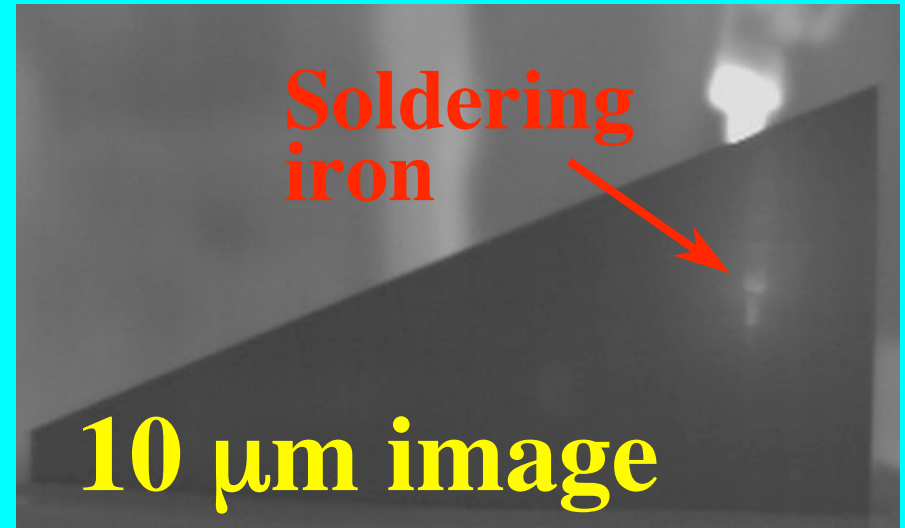
Spent about 400 hours for fabrication
(Ebizuka et. al. SPIE 4842, 2003)

GIGMICS

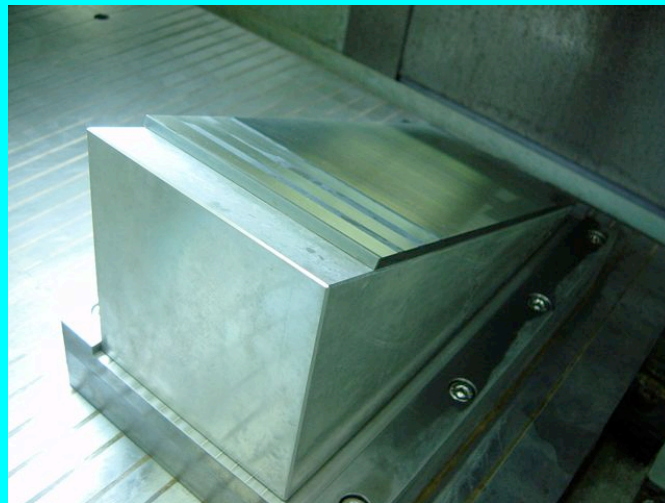


**R~ 50,000@10 μm , developed by Hirahara lab., Nagoya Univ.
(Hirahara et. al., SPIE 7735, 2010)**

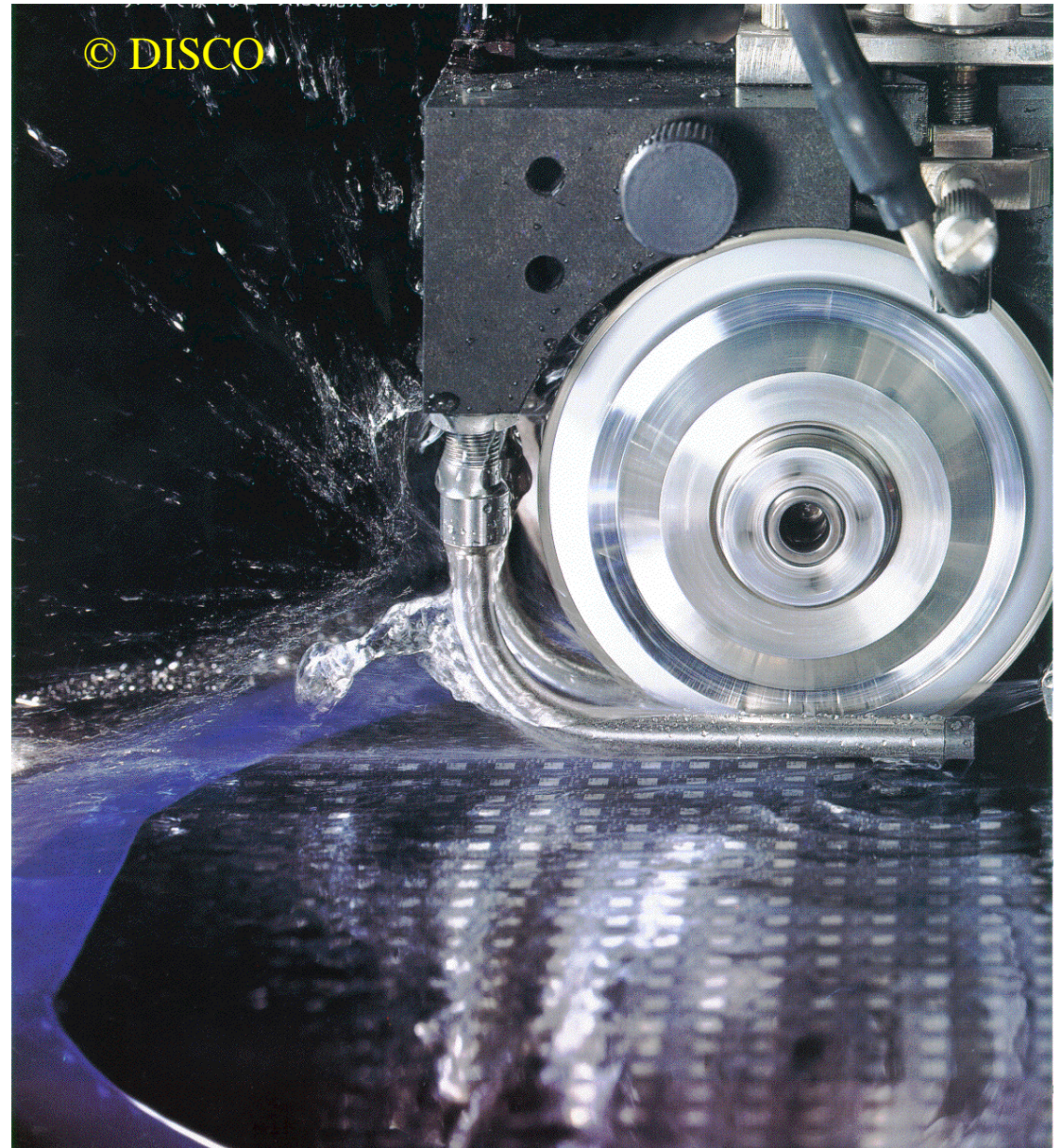
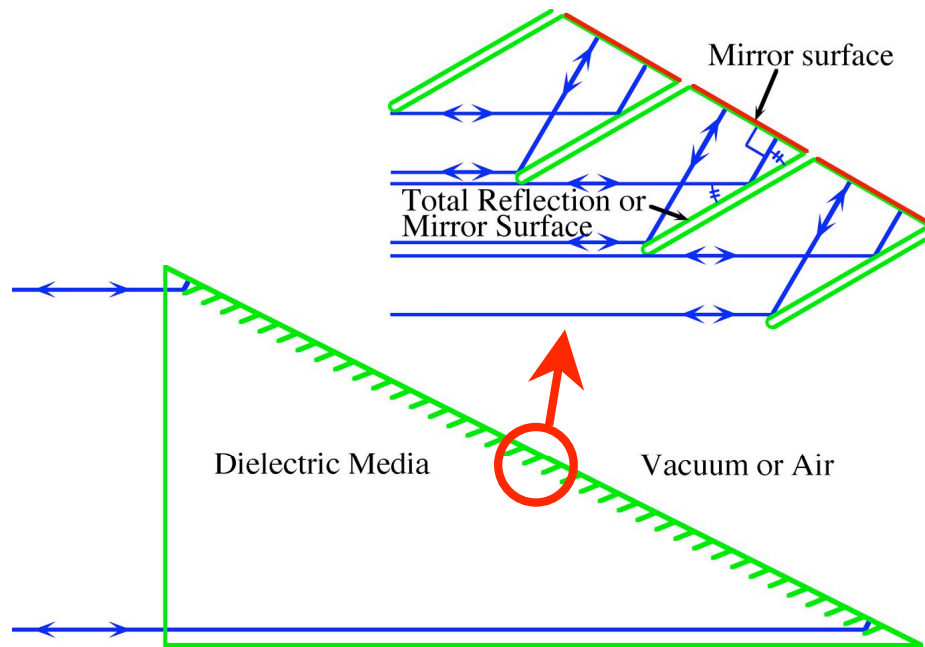
Trial Fabrications of Germanium Immersion Grating for Practical IRHS



$R \sim 200,000 @ 10\mu\text{m}$ → Size: 120 x 120 x 270 mm
→ Fabrication time: several 1000 hours



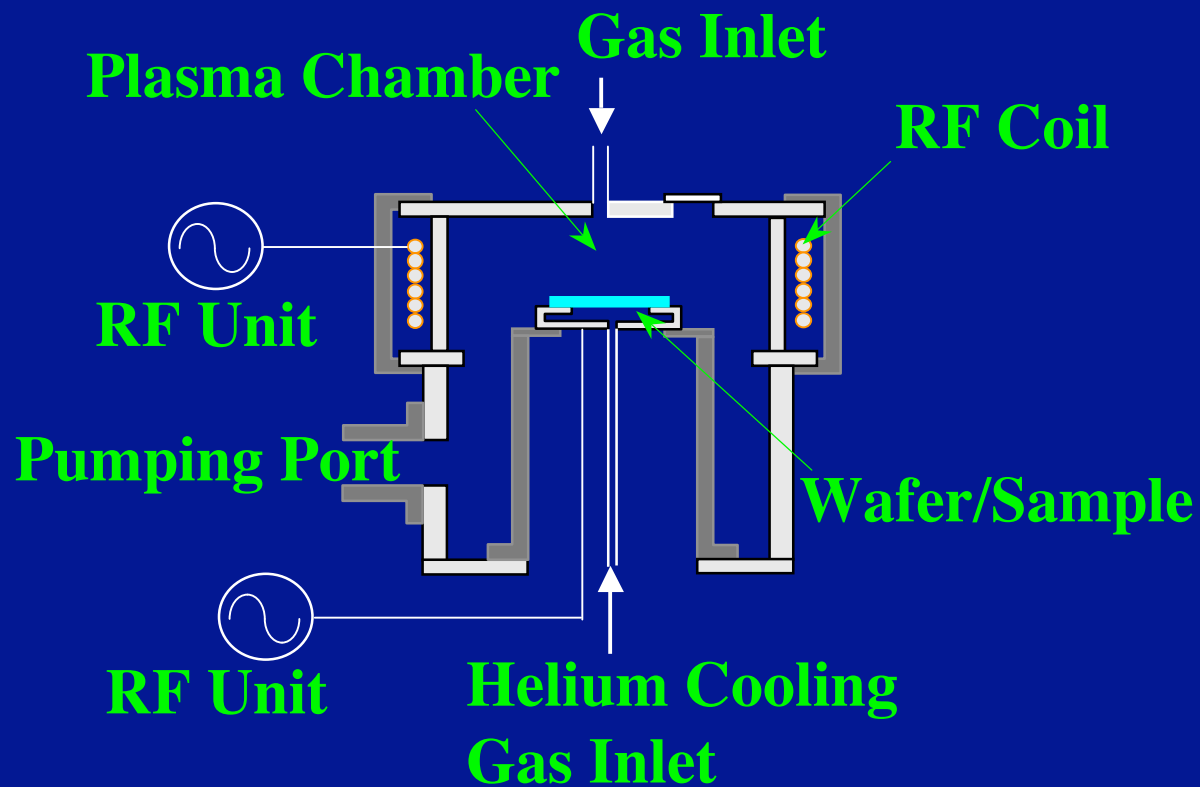
Novel Immersion Grating



- Machining of dicing saw makes smooth surface
 - Easy tooling.
 - Fabrication time for grating with 120 x 120 x 270 mm → Several 100 hours?
- (Ebizuka et. al. SPIE 6273, 2006)

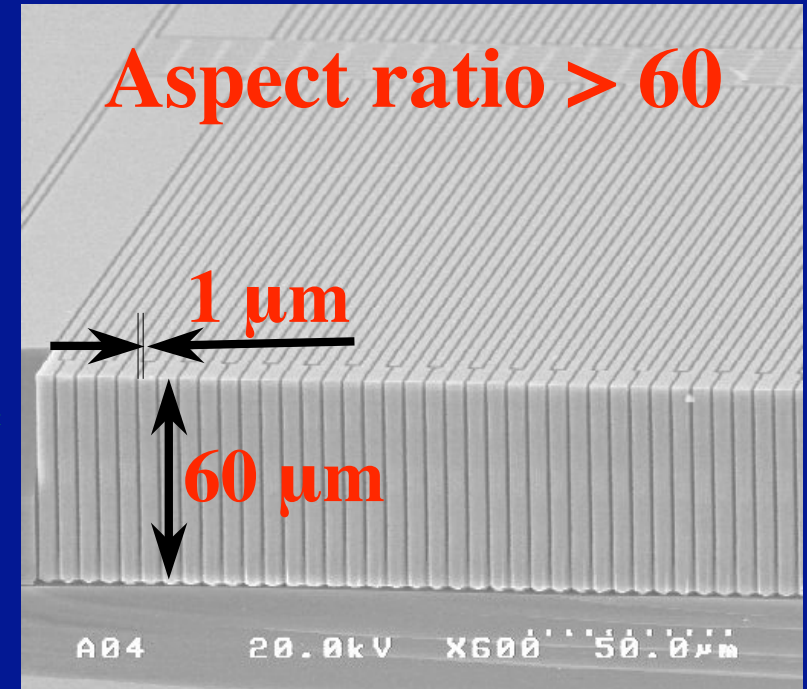
D-RIE (Deep Reactive Ion Etching)

DENSO



ICP Etcher

Inductively Coupled Plasma



G sensor of capacitance type

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Oblique etching → Novel immersion grating for vis. - NIR,
Filling dielectric → Thick binary grating,
Filling metal → Quasi-Bragg grating.

Collaborations with National Institute of Astronomy in Italy and Nagoya University

Two researcher of Osservatorio Astronomico di Brera, Dr. Filippo Maria Zerbi and Dr. Andrea Bianco, visited to NAOJ to discuss about development of novel gratings in the beginning of November 2010.



Filippo and Andrea had obtained a grants for optics of E-ELT for five years.

We will start the collaboration on the novel gratings for next generation instruments of E-ELT, TMT, VLT and Subaru Telescope.

Conclusions

- **VPH grating is useful for lower dispersion.**
- **Bandwidth of VPH grating decrease in higher dispersion ($\alpha < 30^\circ$).**
- **Quasi-Bragg grating and thick binary grating are utilized for an echelle spectrograph.**
- **Novel immersion grating achieves small scattering loss and reduces fabrication cost.**
- **Deep reactive ion etching is hopeful method for fabrications of the high dispersion gratings.**